Photonics Technology Will Transform the Software and Hardware of Telecommunications

Zoar C. Flores, Miguel F. Rocha, and María R. Osnaya
E-mail: ing.zoar_flores@hotmail.com

Eduardo Andrade and Carlos E. Canto
Ifunam, Av. Investigación S/N Coyoacán Mexico D.F, 04510, Mexico
E-mail: andrade@fisica.unam.mx

Miguel E. Rocha
Physics Department, ISB 313, University of California, Santa Cruz, CA 95064
E-mail: migroch@gmail.com

María I. Rocha
Institut Jean Lamour, UMR 7198 CNRS-Universite de Lorraine, ENSTIB, 27 rue Philippe Seguin, BP 1041
E-mail: maribel.rocha.unam@gmail.com

Abstract—Optics is the old and venerable branch of physics that involves the generation, propagation and detection of light. Three key developments achieved are responsible for rejuvenating the optical and its growing importance in modern technology, Laser, low loss optical fibers, transmitting signals. Surge the term Photonics, reflecting the important link between the applied optics and electronics. Electronics and control involves flow of electric charge in a vacuum or matter, involving control Photonics photon in free space or in the field. Both disciplines relate clearly since electrons typically control the flow of photons, and photons control the flow of electrons. Photonics thus the term reflects the importance of nature of the photon of light in the description of the operation of many optical devices. Photonic chip that may be a precursor of the programmable quantum processors can be generated, manipulated and measured entirely on a chip. As a result of these developments, new disciplines and new terms that describe:

- The production of low-loss optical fibers
- Signal transmission

This has taken on increased importance not only in physics but in other sciences, engineering, industry and daily life [1]. As the dominant factor is the discovery and development of many forms of laser. The remarkable properties of the coherent radiation from a laser device have led to a wealth of new techniques in physics and nonlinear optics, cooling and grouping of atoms, electro dynamics of femtosecond optical. It has also engendered a deep understanding of optical radiation involved in coherence and quantum optics and optical coherence techniques have tended a major impact on atomic physics [2]. As a result of these developments, new disciplines emerge and new terms that describe:

- Electro-optic is usually reserved for optical devices in which electrical effects play an important role (laser, electro-optical modulators and switches)
- Optoelectronics typically refers to devices and systems that are essentially electronic in nature, but involve light (light emitting diode devices, liquid crystal display and arrangements of photo detectors).
- Quantum Electronics used in connection with devices and systems that are mainly based on the interaction of light with matter (Laser and used for optical amplifiers and optical wave mixing nonlinear optical devices).
- Quantum Optics studies and coherent quantum properties of light.
- Lightwave technology is used to describe devices and systems that are used in optical communications, optical signal processing and optical metrology.

Index Terms—optics, photonics, electronics, laser

I. INTRODUCTION

Optics is the old and venerable branch of physics that involves the generation, propagation and detection of light. Three key developments made in the last 40 years are responsible for the rejuvenation of optics and their growing importance in modern technology with a revolution:

- The invention of the laser

Manuscript received May 22, 2015; revised November 26, 2015.
Although there is no complete agreement on the precise use of these terms, there is general consensus on its meaning.

II. EXPERIMENTAL DEVELOPMENT

In analogy with electronics, in recent years the term Photonics arises, reflecting the important link between the applied optics and electronics, wrought by the growing role that materials and semiconductor devices play in photonic systems [3]. The field of optics is large and continues to maintain high potential for exploitation. Electronics and control involves flow of electric charge in a vacuum or matter, involving control Photonics photon in free space or in the field. Both disciplines relate clearly since electrons typically control the flow of photons, and photon electron flow control. As in modern optics is now given equal emphasis on aspects of photon wavelength of the optical radiation, this Photonics term reflects the importance of both aspects in understanding new developments that the laser has brought to the field, the development of fiber optical and semiconductor technology for optical emitters and detectors [4]. Thus the term Photonics reflects the importance of the nature of photon of light in the description of the operation of many optical devices.

III. RESULTS AND DISCUSSION

Theoretical basis of photonics

A. Wave Equations and Non-Linear Anisotropic

The electric displacement vector birthday in the media:

\[ D(r,t) = E(r,t) + P(r,t) + P_{NL}(r,t) \]  

(1)

Operating analogously to the isotropic case

\[ \nabla^2 E - \nabla \cdot (\mu_0 E) - \frac{1}{\varepsilon_0 c^2} \frac{\partial^2 E}{\partial t^2} - \mu_0 \frac{\partial^2 P_{NL}}{\partial t^2} = \mu_0 \frac{\partial^2 P_{NL}}{\partial t^2} \]  

(2)

Note that the nonlinear source term contribution acts as:
- In the linear regime is necessary that: PNL = 0
- There are situations in which the dielectric susceptibility tensor depends on the electric field E. This gives rise to another kind of nonlinearities which cannot be described by a nonlinear polarization.

\[ n_0 = \sigma I_{0}(N_{D_i} - N_{A_i}); \frac{\partial n_0(t)}{\partial t} = \frac{\partial N_{D_i}}{\partial t}; N_{D_i} \approx N_x \]

- One of the best examples is not photorefractive nonlinearity.
- In this case: \( eL = eL(E) \)

B. Medium Crystal Symmetry

- Crystalline materials can be classified into 32 classes crystal point groups or grouped in seven crystallographic systems:
  - Cubic, trigonal, tetragonal, hexagonal, orthorhombic, monoclinic and triclinic[5].
- From the optical point of view any crystal belongs to one of the following 3 groups: isotropic, uniaxial, and biaxial.

- Classification is determined by the symmetry of the tensor diagonalizable:
  \[ \varepsilon L = \varepsilon_{ij} \]
  - The principal axes of the tensor are designated as principal dielectric axes.
  - In a non-dissipative medium density electric power inside thermodynamic equilibrium conditions is:
    \[ U_x = \frac{1}{2} E \cdot D = \frac{1}{2\varepsilon_0} \left( \frac{D_x^2}{\varepsilon_x} + \frac{D_y^2}{\varepsilon_y} + \frac{D_z^2}{\varepsilon_z} \right) \]  
    (3)
  - The main axes are associated with the index ellipsoid Fig. 1:
    \[ \frac{x^2}{s_x} + \frac{y^2}{s_y} + \frac{z^2}{s_z} = 1 \]  
    (4)

Figure 1. a. Ellipsoid of indices, b. Special case: Media uniaxial.

C. Electro-Optical Effect Linear and Quadratic

- Certain materials change their optical properties when subjected to electric fields.
• Electro-Optical Effect

The change that occurs in the refractive index as a result of applying a constant or alternating electric field at lower frequencies. Birefringence of the medium was changed in Fig. 2. The variation of the refractive index due to the application of the field is Electro-optical effect linear and quadratic Table I.

\[ \Delta \left( \frac{1}{n^2} \right) = rE + gE^2 \]  \hspace{1cm} (6)

<table>
<thead>
<tr>
<th>TABLE I. SOME CONSTANTS OF ELECTRO-OPTICAL</th>
</tr>
</thead>
<tbody>
<tr>
<td>Material</td>
</tr>
<tr>
<td>LiNbO₃</td>
</tr>
<tr>
<td>LITaO₃</td>
</tr>
<tr>
<td>GaAs</td>
</tr>
<tr>
<td>HgS</td>
</tr>
<tr>
<td>CdS</td>
</tr>
<tr>
<td>KDP</td>
</tr>
<tr>
<td>ADP</td>
</tr>
<tr>
<td>SiO₂ (Quartz)</td>
</tr>
</tbody>
</table>

D. Matrices Electro-Optics for Crystal Symmetry

\[
\begin{pmatrix}
0 & -r_{32} & r_{33} \\
0 & r_{32} & 0 \\
0 & 0 & r_{33}
\end{pmatrix}
\begin{pmatrix}
0 & 0 & 0 \\
0 & 0 & 0 \\
0 & 0 & 0
\end{pmatrix}
= \begin{pmatrix}
r_{32} & 0 & 0 \\
r_{33} & 0 & 0 \\
r_{33} & 0 & 0
\end{pmatrix}
\]

\[
\Delta n = \frac{3}{4\varepsilon_r\mu_0} x^{(3)} I = n_2 I
\]  \hspace{1cm} (8)

\[
n(I) = n_0 + \Delta n(I) = n_0 + n_2 I
\]  \hspace{1cm} (9)

Initially a homogeneous medium becomes inhomogeneous due to the presence of light, following the same dependency (local) the spatial or temporal wave profile.

It can lead to nonlinear optical phenomena as individual autofocus and optical solutions.

F. Fundamentals of Photo-Refractory Effect

Material refractive photo: A means is conductive and electro-optical picture. Their optical properties are characterized by the electro-optical tensor the photo refractive effect is defined by four processes:

• Photoionization Fig. 3: As a result of the intensity of incident light at a particular frequency broadcast. Part of donor impurities is ionized.
• Dissemination: Generation and transport of free carriers in the energy bands (conduction and valence)
• Recombination Fig. 3: Re-trapping of free carriers by the donor impurity.
● Generating an electric field: load redistribution and create a very strong electric field (about 10⁴ V/cm) Fig. 4 Space charge field of refractive index modulation load.

Figure 3. As a result of the intensity of incident light at a particular frequency broadcast. Part of donor impurities is ionized.

Fig. 3 a) Photoionization: Impurities of Fe²⁺Fe³⁺ impurities pass rate +

c) Recombination: The Fe³⁺ions are converted into ions Fe²⁺.

Parameters involved in the process are:

N_D: donor density

N⁺D: density of donor’s photoionized

N₋A: photoionized acceptor density

n: electron density

Figure 4. The generating an electric field and the spatial distribution of the loads.

G. Microscopic Analysis: Network Formation Index

The space charge field E modulates the refractive index via electro-optical effect:

\[ \Delta \left( \frac{1}{n} \right)_{ij} = \sum_k r_{ik} E^k + \sum_k s_{ik} E^k E^l \]  

(10)

In most cases the photo refractive materials Pockels effect is responsible for the modulation index. Induces a variation:

\[ \Delta n_{ij} = -\frac{1}{2} n_0^3 \sum_{k=1}^3 r_{ijk} E^k \]  

(11)

No need lighting with very intense beams. Example: low power lasers <1W for modulation index between 10⁻⁴ y 10⁻³. When the direction of the electric field is parallel to a principal axis of the crystal Fig. 5 and is operated under conditions of partial coherence can be a scalar unit:

\[ \Delta n = -\frac{1}{2} n^3 \Delta \left( \frac{1}{n^2} \right) = -\frac{1}{2} n^3 r E' \]  

(12)

A modulated intensity is obtained:

\[ I = I_0 + m \cos \left( \theta - \Delta \phi \right) \]  

(13)

RefRACTIVE index, electro-optical coefficients and magnitude of the effect of some photo-refractive materials [7].

Figure 5. We assume that the diffraction of light by the network is generated index Bragg regime.

● Basic differential equations: Equation Kukhtarev

Formulation introduced by Kukhtarev in 1979, describes a basic model for temporal variation in the number of donors in the presence of a phenomenon photoionization. An initial balance equation is established:

\[ \text{Ionized donor variation ratio} = \text{donors created - proportion of recombined the proportion of donors generated is proportional to the incident intensity and the number of non-ionized donors. photoionization cross section coefficient defined:} \]

\[ G = \sigma I (N_D - N'_D) \]  

(14)

The temporal evolution of photoionized donors is:

\[ \frac{\partial N'_D}{\partial t} = G - \frac{n}{\tau} t < 10^{-9} s \]  

(15)

It also fulfills:

\[ \frac{\partial N_{-A}^+}{\partial t} = \frac{\partial N_{+D}^-}{\partial t} \]  

(16)

First-order solution to Eq. of Khutarev

\[ \frac{\partial n}{\partial t} + Y \nu N_0 N_{-A}^+ = \sigma I_0 (N_D - N'_D); \frac{\partial n(t)}{\partial t} = \frac{\partial N_{+D}^-}{\partial t}; N_{+D}^- = N_{-A}^+ \]  

(17)

\[ n_0 = \sigma I_0 (N_D - N'_D) \tau_i \left[ 1 - e^{-\frac{t}{\tau_i}} \right] \]  

(18)

τᵢ, half-life of e⁻

● Numerical behavior of the temporal evolution of the electron density in the first approximation

Figure 6. The numerical behavior of the temporal evolution of the electron density in the first approximation.

For a solution of first order linearization is introduced into the system of equations Fig. 6.
It is assumed that the fundamental process parameters have no spatial dependence.

It is assumed that the half-life of the electrons is practically equal to the time of recombination.

Examples of non-linear devices LiNbO3 Fig. 7

![Electro-optical device](image1.png)

![Electro-optical modulator](image2.png)

Figure 7. a. Electro-optical device. b Electro-optical modulator.

Definition: a liquid crystal is a state of matter intermediate between solid and liquid, see Fig. 8.

![Solid, Liquid Crystal, Liquid](image3.png)

Figure 8. The liquid crystal.

The most common is called nematic liquid crystal:
1) The set of molecules are oriented, but each molecule lacks positional order. The direction of alignment of the molecules defines a nematic director: n.
2) Not ferroelectric.
3) Have a permanent dipole moment.

Electrical properties of liquid crystals:
1) Molecules form a permanent dipole moment.
2) The effect of the action of an electric field $E$ is studied on the structure of the liquid crystal
3) is induced polarization $P = (\varepsilon - 1) \varepsilon 0 E$
4) The degree of polarization depends on the mutual orientations between the electric field and the director $n$ Fig. 9.

![Textures phasenematic](image4.png)

Figure 9. The optimal orientation is obtained when the $E$ vector is parallel to the direction of the vector $n$.

Electric displacement:
Energy per unit volume associated with the field:

$$D = \varepsilon_i E + (\varepsilon_z - \varepsilon_i)(nE)n$$  \hspace{1cm} (19)

$$F = -\frac{1}{4} \pi \int \mathbf{D} \cdot d\mathbf{E} = -\frac{\varepsilon_1}{8\pi} E^2 - (\varepsilon_z - \varepsilon_i)(nE)^2$$  \hspace{1cm} (20)

Polarization in terms of susceptibility $X$:

$$P = \mathbf{P}_L + \mathbf{P}_M$$

$$P = \varepsilon_0 \left[ x^{(1)} E + x^{(2)} E E + x^{(3)} + \ldots \right]$$  \hspace{1cm} (21)

$$P(t) = \sum_{i=1}^{N} p(t)$$  \hspace{1cm} (22)

$$P^i(\omega) = \varepsilon_0 \left[ x^{(i)} (\omega_1, \omega_2, \ldots, \omega_n) \hat{E}(\omega_1) \hat{E}(\omega_2) \ldots \hat{E}(\omega_n) \right]$$  \hspace{1cm} (23)

For a liquid crystal with linear behavior:

$$\begin{pmatrix}
P_x \\
\varepsilon_0 \\
0 \ v \\
0 \ v \\
\end{pmatrix}$$  \hspace{1cm} (24)

Electric susceptibility tensor of a nematic liquid crystal

$$\begin{pmatrix}
P_x \\
\varepsilon_0 \\
0 \ v_1 \\
0 \ v_2 \\
\end{pmatrix}$$  \hspace{1cm} (25)

Degree of anisotropy:

$$\Delta \varepsilon = \varepsilon_{||} - \varepsilon_{\perp}$$  \hspace{1cm} (27)

Properties:
Structural changes depending on the temperature and the application of an electron. It confers the ability to operate as an electro-optical device Fig. 10.

![The light modulating liquid crystals](image5.png)

Figure 10. The light modulating liquid crystals.

Textures phasenematic

(a) texture of schlieren. (b). homeotropic texture. (C). with white light. and (d). Green light

![Textures](image6.png)

Figure 11. Conoscopic image with: (a). texture of schlieren. (b). homeotropic texture. (C). with white light. and (d). Green light

![Textures nematic coli cell polarize polarizer twisted nematic electric field textures phase.](image7.png)

Figure 12. Textures nematic coli cell polarize polarizer twisted nematic electric field textures phase.
Almost flat cell CL, located between two crossed polarizers. Images observed with a microscope Fig. 11 and Fig. 12. Absorption of photons, see Fig. 13 and Fig. 14.

Figure 13. Absorption coefficient (α) vs. wavelength (ν) for various semiconductors (Data selectively collected and combined from various sources).

Figure 14. (a) Photon absorption in a direct bandgap semiconductor. (b) Photon absorption in an indirect bandgap semiconductor (VB, valence band; CB, conduction band).

- Fundamental parameters of quantum efficiency and responsivity
  Quantum efficiency
  \[ n = \frac{\text{Number of EHP generated and collected}}{\text{Number of incident photons}} \] (28)

  Responsivity Fig. 14.
  \[ R = \frac{\text{Photocurrent (A)}}{\text{Incident Optical Power (W)}} = \frac{I_{\text{ph}}}{P_0} \] (29)

  Responsivity (A/W)

Figure 15. Wavelength (nm) Responsivity (R) vs. wavelength (2) for an ideal photodiode with QE = 100% (i = 1) and for a typical commercial Si photodiode.

H. Spatial Light Modulators

Object beam modulation [9]: Operation necessary for storing encoded in 2-D (1 page)

Types of spatial light modulator (Spatial Light Modulators, SLM):
- Liquid crystals (twisted nematic):
  Parameters: frame rate (frame rate): 30 ms. Spatial resolution: 1.024X1.024 pixels. Pixel Size: 15-8p, m
- Ferroelectric crystals: 100p, s, similar spatial resolution.
- Deformable mirrors (Deformable Mirror Devices, DMD): 2KHz, 850X600 pixels, high contrast: 800: 1

In general, the sampling operates SLM (discretized) the optical signal (*). The transfer function is:

\[ t(x, y) = \sum_{n=1}^{N} \sum_{m=1}^{M} \alpha_{m,n} \text{rect}\left(\frac{x}{p} - m\right) \text{rect}\left(\frac{y}{p} - n\right) \] (30)

\[ \alpha_{m,n} = \{1,0\}; \text{binarized signal} \]

Detectors
- Charge Coupled Devices (CCD)
- Spatial resolution: pixels 1.024X1.024

Quantum Efficiency Fig. 15: 70%

\[ P(\bar{r}, t)\Delta t = c\alpha S\Delta t \langle \hat{I}(\bar{r}, t) \rangle \] (31)
σ: quantum efficiency (photoelectrons / photon)

Figure 16. The parameters involved in the quantum efficiency.

Read speed: 15 Mpixels / s, using 64 parallel channels

APS CMOS Fig. 16 (Complementary Metal-Oxide Semiconductor, Active Pixel Sensor)

Developed at the Jet Propulsion Laboratory (Ca, USA)

It is characterized by capturing digital input signals and non-digital and convert them into digital output signals. Pixel size: 5 μM

High speed reading: 524 Mpixels / s

Use silicon microtechnology structure chip.

Figure 17. a. APS CMOS chip structure. b. An enlarged view of the structure. c. Operational response

IV. CONCLUSIONS

In conclusion, photonics is another branch of science which has greatly helped to advance technology as it has many applications, we can say that we are not very accustomed to using in daily life photonic devices, but increasingly photonic applications are more present around us.

The fact that photons to be "lighter" than electrons, cause less heat to dissipate and are not subject to the restrictions caused by the capacitances, inductances and resistances that can be created.

An approximate model for the estimation of non-intrinsic photonic efficiencies heterogeneous photocatalytic reaction systems based on a parameter of photon efficiency independent intrinsic type reactor was developed; and the product of two functions, one photon energy absorption and other absorption correction effect of catalyst loading, and the geometry of the initial substrate concentration. The postulates were validated using dichloroacetic acid as a standard substance. It was found that the model is highly predictive for photonic efficiencies photodegradation processes of this component with smaller relative errors 1.8%

REFERENCES


Ing. Zoar C. Flores Cabrera. has got his technical degree in Metrology and Quality Control at Centre for Science and Technology Studies “Carlos Vallejo Marquez”, Mexico City, Mexico. She has got his engineering degree in Control and Automation at School of Mechanical and Electrical Engineering of National Polytechnic Institute Mexico City, Mexico 2008. She has studied of the Master in Educational Sociology level by Institute of Engineering in Automotive Mechanic, CEDVA Mexico. In ESIME-Z, IPN, Mexico served as: professor researcher, coordinator applied physics Laboratory.

Ph.D. Eduardo Andrade Ibarra, Dr. Univ. of Rice, USA, (1972). Analysis of heavy metal pollution in water and other liquids.Determination of lithium ionzeolitic materials modified by the bombardment beam of deuterium.Using nuclear techniques for analyzing materials.Research Institute of Physics, experimental Physics Department, UNAM, Mexico.


Dra. Maria I. Rocha. Degree of Doctor, by the UPV and UCL. She graduated as Computer Engineer in September 2006 by the Autonomous University of Mexico (UNAM). Speciality Engineer Bioelectronics at the Polytechnic University of Valencia (UPV), Spain, in 2008. 2011 conducted a research stay of one academic year at the Catholic University of Louvain (UCL), Belgium, where he worked in a cleanroom to perform...
microfabrication sensor surface acoustic wave used to carry out his doctoral thesis. Research found the bioelectronics, biosensors, the piezoelectric acoustic sensors and their applications, transducers and micro fabrication.

M. S. C. Canto. Professor of Subject A, Assistant Professor of Subject B, Department of Physics, UNAM, Mexico. Analysis of Heavy metal pollution in water and other liquids. Determination of lithium in zeolitic materials modified by the bombardment beam of deuterium. Using nuclear techniques for analyzing materials. Research Institute of Physics, experimental Physics Department, UNAM, Mexico.

Maria R. Osnaya. Studying at School Superior of Mechanical and Electrical Engineering of IPN, the Automation and Control Engineering degree. Working as scholar in the Institutional Programme of training of researchers of the National Polytechnic Institute acquiring experience as a researcher. Is co-author of some papers presented in national and international conferences. Co-author of articles and Software to Determine the Optimal Value of Resistance by Current Measurements for triacs and SCRs Control. Implementation of an Algorithm to Calculate the Inverse Square Root Operation in a Microcontroller.